



PATENT

61 AF
2811

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 09/881,005

Filed: June 14, 2001

Inventor: Horiuchi et al.

Title: **Multi-Layered Semiconductor
Device and Method for
Producing the Same**

Atty Doc. No.: 149-01

Art Unit: 2811

Examiner: Doug Owens

Certificate of Class Mail

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Dara Salgado

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- 3) Postcard to be date-stamped and returned.

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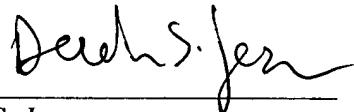
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No fees are believed to be required. In the event that an additional fee is required with respect to this communication, the Commissioner is hereby authorized

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Respectfully submitted,



Date: August 17, 2004

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